



THE 8TH U.S. GALLIUM OXIDE WORKSHOP
AUGUST 4-6, 2025

8TH U.S. GALLIUM OXIDE WORKSHOP WORKSHOP PROGRAM

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Sriram Krishnamoorthy, University of California - Santa Barbara

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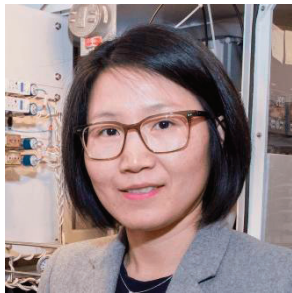
Plenary Speakers



Monday, August 4th | 08:30 - 09:15

Ga₂O₃ Materials: Current Status and Future Prospects

Kohei Sasaki, Novel Crystal Technology, Inc.



Tuesday, August 5th | 8:30 - 9:30

Advancements in the Epitaxial Growth of Ga₂O₃ Thin Films, Alloys, and Heterostructures

Hongping Zhao, The Ohio State University



Wednesday, August 6th | 8:30 - 9:30

The Roadmap Towards Ga₂O₃ Technology Insertion

Andrew Green, Air Force Research Lab

Invited Speakers



Monday, August 4th | 09:15 – 09:45

**Bulk Growth of Offcut (100) Ga_2O_3 by EFG:
Establishing a Domestic Source of Gallium Oxide
Substrates**

Drew Haven, Luxium Solutions



Monday, August 4th | 12:00 – 12:30

**Nitrogen-Doped Ga_2O_3 Thin Films Grown by
Molecular Beam Epitaxy**

*Masataka Higashiwaki, Osaka Metropolitan
University*



Monday, August 4th | 14:00 – 14:30

**Illuminating Features in $\beta\text{-Ga}_2\text{O}_3$ with
Photoluminescence and Raman Spectroscopy**

Matthew McCluskey, Washington State University

Invited Speakers



Monday, August 4th | 16:00 – 16:30

Synthesis of UWBG GeO₂ and GeSnO₂ semiconductors

Rebecca L (Becky) Peterson, University of Michigan



Tuesday, August 5th | 11:00 – 11:30

MOCVD Synthesis and in Situ Etching of Ga₂O₃

Hari Nair, Cornell University



Tuesday, August 5th | 14:00 – 14:30

Dielectric Integration for Ga₂O₃ MOS Devices

Ahmad Ehteshamul Islam, Air Force Research Lab



Tuesday, August 5th | 16:00 – 16:30

Atomic Structure of the Ga₂O₃-Based PN Junction Interface

Jinwoo Hwang, The Ohio State University

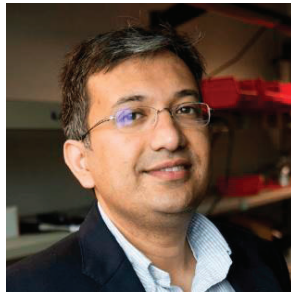
Invited Speakers



Wednesday, August 6th | 14:00 – 14:30

Reaching beyond Diamond to Sapphire a 7 eV Semiconductor

Darrell Schlom, Cornell University



Wednesday, August 6th | 15:40 – 16:15

Recent advancements in Gallium Oxide based power electronics

Faisal Khan, National Renewable Energy Laboratory

Technical Program: Monday, August 4

08:00 - 08:30

Registration

08:20 – 08:30

Opening Remarks

Co-Chairs: Sriram Krishnamoorthy (University of California - Santa Barbara),
Michael Scarpulla (University of Utah)

08:30 – 09:15

Plenary Talk - Advances in Ga₂O₃ Crystal Growth and Device Applications

Speaker: Kohei Sasaki (Novel Crystal Technology)

09:15 - 10:30

Technical Session 1: Bulk Crystal Growth

Session Chairs: Michael Scarpulla (University of Utah)

09:15 – 09:45

Invited Talk - Bulk Growth of Offcut (100) Ga₂O₃ by EFG: Establishing a Domestic Source of Gallium Oxide Substrates

Speaker: Drew Haven (Luxium Solutions)

09:45

Bulk Crystal Growth of β -Ga₂O₃ Crystals from the Melt Without Precious-Metal Crucible Using Oxide Crystal Growth from a Cold Crucible Method

Akira Yoshikawa (Tohoku University)

Technical Program: Monday, August 4

10:00

Optimization of Axial Vertical Temperature Distribution and Experimental Verification in 4-Inch β -Ga₂O₃ Crystal Growth Using the Vertical Bridgman Method

Dae-Uk Kim (DONG-EUI University, Korea (South)); Seora Son (AXEL Co, Ltd., Korea (South)); So-min Shin (Dong Eui University, Korea (South)); Yunjin Kim (DongEui University, Korea (South)); Won-Jae Lee and Junggon Kim (Dong-Eui University, Korea (South)); Su-Min Choi (AXEL, Korea (South)); Kwang-Hee Jung (Dong-Eui University, Korea (South)); Dong-Jun Lee, Hwang-Hee Lee and Jin-Ki Kang (AXEL, Korea (South)); Mi-Seon Park, Eun-Seo Lee and Eun-Jeong An (Dong-Eui University, Korea (South))

10:15

Thermal Field Engineering Using Ceramic Materials to Optimize β -Ga₂O₃ Crystal Quality by EFG Method 5

Tae-Hun Gu and A-Ran Shin (Pukyong National University, Korea (South)); Yun-Ji Shin and Seong-Min Jeong (Korea Institute of Ceramic Engineering and Technology, Korea (South)); Si-Young Bae (Pukyong National University, Korea (South))

10:30 – 11:00

Coffee Break

Technical Program: Monday, August 4

11:00 – 12:00

Technical Session 2: Substrates & Epitaxial Growth

Session Chair: Matthew McCluskey (Washington State University)

11:00

Development of a Manufacturing Process for Epi-Ready Mismatch (100) β -Ga₂O₃ Substrates

Daniel Erdely (Penn State University, Applied Research Laboratory, USA); Robert M Lavelle (Penn State University Applied Research Laboratory, USA); William Everson (Penn State University, Applied Research Laboratory, USA); Luke Lyle (Penn State University, Applied Research, USA); Scott W Pistner, Samuel R Hallacher and Shawn L Watkins (Penn State University Applied Research Laboratory, USA); Drew Haven, David Joyce and John Frank (Luxium Solutions, Inc., USA); Joan M Redwing (The Pennsylvania State University, USA); David Snyder (Penn State University, Applied Research Laboratory, USA)

11:15

Characterization of Mismatch (100) β -Ga₂O₃ Substrates to Enable Bulk Growth and Processing Improvements

Robert M Lavelle (Penn State University Applied Research Laboratory, USA); William Everson and Daniel Erdely (Penn State University, Applied Research Laboratory, USA); Luke Lyle (Penn State University, Applied Research, USA); Scott W Pistner, Samuel R Hallacher and Shawn L Watkins (Penn State University Applied Research Laboratory, USA); Drew Haven, David Joyce and John Frank (Luxium Solutions, Inc., USA); Joan M Redwing (The Pennsylvania State University, USA); David Snyder (Penn State University, Applied Research Laboratory, USA)

11:30

Fabrication of (010) and (001) β -Ga₂O₃ Thin Film Composite Wafers

Michael E Liao (Apex Microdevices, USA); Mark Goorsky (University of California, Los Angeles, USA); Piyush J. Shah (Apex Microdevices, USA)

Technical Program: Monday, August 4

11:45

Evaluation of the Impact of Substrate Processing on (010) β -Ga₂O₃ Epitaxial Growth

Robert M Lavelle (Penn State University Applied Research Laboratory, USA); William Everson and Daniel Erdely (Penn State University, Applied Research Laboratory, USA); Luke Lyle (Penn State University, Applied Research, USA); Scott W Pistner, Samuel R Hallacher and Connor M Beakes (Penn State University Applied Research Laboratory, USA); Kevin Leedy and Adam Neal (Air Force Research Laboratory, USA); Daram N Ramdin (Air Force Research Labs- Contractor & Core4ce, USA); Tom G Jacob (University of Dayton, USA); Allen Brady and Chase Scott (Northrop Grumman Corporation SYNOPTICS, USA); Joan M Redwing (The Pennsylvania State University, USA); David Snyder (Penn State University, Applied Research Laboratory, USA)

12:30 – 14:00

Lunch Break

14:00 – 15:30

Technical Session 3: Epitaxy, Material Characterization & Defects

Session Chair: Masataka Higashiwaki (Osaka Metropolitan University, Japan)

14:00 – 14:30

Invited Talk - Illuminating Features in β -Ga₂O₃ with Photoluminescence and Raman Spectroscopy

Speaker: Matthew McCluskey, (Washington State University)

14:30

Mitigating Unintentional Carbon Incorporation and Characterizing Associated Deep Compensating Centers

Hemant Jagannath Ghadi, Randy Carver, Lingyu Meng, Dong Su Yu, Hongping Zhao and Aaron Arehart (The Ohio State University, USA); Steven Ringel (the Ohio State University, USA)

Technical Program: Monday, August 4

14:45

Non-Equilibrium Defect Formation Energies-What Happens to Defect Concentrations in the Presence of Excess Carriers?

Isaac Thomas and Brian Eisner (University of Utah, USA); Arkka Bhattacharyya and Sriram Krishnamoorthy (University of California Santa Barbara, USA); Thaddeus Asel (Air Force Research Laboratory, USA); Prescott Evans (Azimuth Corporation, USA); Michael Scarpulla (University of Utah, USA)

15:00

Infrared-Active Phonon Modes, Band-to-Band Transitions, and Ultraviolet Dielectric Functions of Unintentionally-Doped ($X < 0.3$) and Silicon Doped ($X < 0.25$) Single Crystal (100) β -(Al_xGa_{1-x})₂O₃

Preston R Sorensen (University of Nebraska-Lincoln)

15:15

Si-Doped β -Ga₂O₃ Films Grown by LPCVD with Controlled Doping, Promising Mobility and High Growth Rates

Saleh Ahmed Khan, Ahmed Ibreljic and A F M Anhar Uddin Bhuiyan (University of Massachusetts Lowell, USA)

15:30 – 16:00

Coffee Break

16:00 – 17:30

Technical Session 4: Epitaxial Growth

Session Chair: Anhar Bhuiyan (University of Massachusetts)

16:00 – 16:30

Invited Talk - Synthesis of UWBG GeO₂ and GeSnO₂ semiconductors

Speaker: Rebecca L (Becky) Peterson (University of Michigan), Ahmad Matar Abed (University of Michigan)

Session Chair: Anhar Bhuiyan

Technical Program: Monday, August 4

16:30

Seed-Driven Stepwise Crystallization for Phase Control in Growing Rutile GeO₂ Films by MOCVD

Imteaz Rahaman, Botong Li, Hunter Ellis, Michael Scarpulla and Kai Fu (University of Utah, USA)

16:45

β -Ga₂O₃ Epitaxial Layer Grown by Liquid Phase Epitaxy

Zhijin Chen, Hiroaki Tadokoro and Taro Takakura (Mitsubishi Gas Chemical Company Inc., Japan); Miyuki Miyamoto, Susumu Innan and Makoto Sasaki (Mitsubishi Gas Chemical Company, Inc., Japan)

17:00

MOVPE Growth and Characterization of β -(Al_xGa_{1-x})₂O₃ Thin Films on β -(Al_yGa_{1-y})₂O₃ Substrates

Saud Bin Anooz, Jana Rehm, Arub Akhtar and Ta-Shun Chou (Leibniz-Institut für Kristallzüchtung (IKZ), Germany); Andreas Fiedler (Leibniz Institute for Crystal Growth - IKZ, Germany); Martin Schmidbauer (Leibniz-Institut für Kristallzüchtung (IKZ), Germany); Zbigniew Galazka (Leibniz Institute for Crystal Growth - IKZ, Germany); Thilo Remmele (Leibniz-Institut für Kristallzüchtung (IKZ), Germany); Martin Albrecht (Leibniz Institute for Crystal Growth - IKZ, Germany); Andreas Popp (Leibniz-Institut fuer Kristallzuechtung, Germany)

17:15

Epitaxial Stabilization of Monoclinic (Al, In, Ga)₂O₃/Ga₂O₃ Heterostructures

Stephen Schaefer, (National Renewable Energy Laboratory)

17:30 – 19:30

GOX Welcome Reception

Location: Cleone Peterson Eccles Alumni House

Address: 155 SOUTH CENTRAL CAMPUS DRIVE SALT LAKE CITY, UT 84112

Technical Program: Tuesday, August 5

08:00 - 08:30

Registration

08:30 - 09:30

Plenary Talk - Advancements in the Epitaxial Growth of Ga₂O₃ Thin Films, Alloys, and Heterostructures

Speaker: Hongping Zhao (The Ohio State University)

09:30 - 10:30

Technical Session 5: MOCVD Growth

Session Chair: Hari Nair (Cornell University)

09:30

Growth of >50micron Thick, <1e16 Doped Ga₂O₃ Layers on SnDoped (001) Substrates by Halide Vapor Phase Epitaxy

Jacob Leach, Caroline Reilly, Heather Splawn and Kevin Udworthy (Kyma Technologies, USA)

09:45

Sub-Nanometer Surface Roughness of 20 μm Thick Homoepitaxial β-Ga₂O₃ on ~3.8° (100) Substrates by MOCVD

Joshua T Buontempo, Cameron A Gorsak and Hari P Nair (Cornell University, USA)

10:00

MOCVD Growth of (010) β- Ga₂O₃ with Fast Growth Rates (> 4.3 μm/H) and Superior Transport Properties

Dong Su Yu, Lingyu Meng and Hongping Zhao (The Ohio State University, USA)

10:15

MOCVD Epitaxy of (001) β- Ga₂O₃ Films with Fast Growth Rates

Lingyu Meng, Dong Su Yu, Md Mosarof Hossain Sarkar and Hongping Zhao (The Ohio State University, USA)

Technical Program: Tuesday, August 5

10:30 – 11:00

Coffee Break

11:00 – 12:00

Technical Session 6: MOCVD Growth

Session Chair: Xiuling Li (University of Texas at Austin)

11:00 – 11:30

Invited Talk - MOCVD Synthesis and in Situ Etching of Ga₂O₃

Speaker: Hari Nair, (Cornell University)

Session Chair: Xiuling Li (Osaka Metropolitan University, Japan)

11:30

Low-Background Carrier Density Intentionally and Unintentionally Doped (010)

β - Ga₂O₃ Drift Layers and Schottky Diodes

Carl Peterson (UC Santa Barbara, USA); Chinmoy Nath Saha, Rachel Kahler, Yizheng Liu, Saurav Roy and Sriram Krishnamoorthy (University of California Santa Barbara, USA)

11:45

Novel Showerhead for Scalable β -Ga₂O₃ MOCVD

William Timothy Brand (Agnitron Technology, Inc., USA & Agnitron Technology, USA); Fikadu Alema and Andrei Osinsky (Agnitron Technology Inc, USA)

12:00

Electrical Transport in δ -Doped β - Ga₂O₃ Grown by MOCVD

Cameron A Gorsak, Pushpanshu Tripathi, Joshua T Buontempo, Bilal Azhar, Chuan F. C. Chang, Joseph E Dill, Salil A Paranjape, Huili Xing, Michael O Thompson, Debdeep Jena and Hari P Nair (Cornell University, USA)

12:30 – 14:00

Lunch Break

14:00 – 15:30

Technical Session 7: Dielectrics, Ion Implantation & Material Processing

Session Chair: Kai Fu (University of Utah)

Technical Program: Tuesday, August 5

14:00 – 14:30

Invited Talk - Dielectric Integration for Ga₂O₃ MOS Devices

Speaker: Ahmad Ehteshamul Islam (Air Force Research Lab)

Session Chair: Kai Fu (University of Utah)

14:30

Investigation of SiO₂: HfO₂ Composition Effects on ALD HfSiO_x as Gate Dielectric on β -Ga₂O₃ (001)

Xin Zhai and Zhuoqun Wen (University of Michigan, USA); Pengcheng Lu and Kai Sun (University of Michigan, Ann Arbor, USA); Elaheh Ahmadi (University of California, Los Angeles, USA)

14:45

Characterization of Ion-Implanted Nitrogen as a Compensating Acceptor in β -Ga₂O₃

Jacob S Breakfield (Air Force Research Laboratory, USA); Zachary Weber (The Ohio State University, USA); Nolan Hendricks and Joshua Piel (Air Force Research Lab, USA); Andrew Green (AFRL, USA)

15:00

High-Density Si Doping into Ga₂O₃ by Hot Implantation

Kotaro Yagi (Osaka Metropolitan University, Japan); Daisuke Matsuo, Shun Konno and Shinya Takemura (Nissin Ion Equipment Co., Ltd., Japan); Kosuke Usui (Nissin Ion Equipment Company Limited, Japan); Yasunori Andoh (Nissin Electric Co., Ltd., Japan); Kohei Tanaka (Nissin Ion Equipment Co., Ltd., Japan); Masataka Higashiwaki (Osaka Metropolitan University, Japan & National Institute of Information and Communications Technology, Japan)

15:15

Effect of NiO_x Sputtering and ICP Dry Etching on (010) β -Ga₂O₃ Films Grown by MOCVD

Chinmoy Nath Saha (University of California Santa Barbara, USA); Carl Peterson (UC Santa Barbara, USA); Yizheng Liu and Sriram Krishnamoorthy (University of California Santa Barbara, USA)

15:30 – 16:00

Coffee Break

Technical Program: Tuesday, August 5

16:00 – 17:30

Technical Session 8: Heterojunctions, Epitaxy & Wet Etching

Session Chair Ahmad Ehteshamul Islam (Air Force Research Lab)

16:00 – 16:30

Invited Talk - Atomic Structure of the Ga₂O₃-Based PN Junction Interface

Speaker: Jinwoo Hwang (The Ohio State University)

Session Chair: Ahmad Ehteshamul Islam (Air Force Research Lab)

16:30

MOCVD-Grown n-Ga₂O₃/p-GaN Heterojunction Diodes with Atomically Sharp Interfaces

Zhongjie Ren, Sangbin Park and Xun Zhan (The University of Texas at Austin, USA); Aadil Waseem (University of Austin Texas, USA); Scott A Wicker Jr (The University of Texas at Austin, USA); Xiuling Li (University of Texas at Austin, USA)

16:45

Thermal Degradation and Performance Enhancement of β -Ga₂O₃ Diodes Using CNT/ Ga₂O₃ Heterojunctions

Hunter Ellis and Botong Li (University of Utah, USA); Wei Jia (The University of Utah, USA); Haoyu Xie, Jichao Fan, Apostoli Hillas and Michael Scarpulla (University of Utah, USA); Berardi Sensale Rodriguez (The University of Utah, USA); Weilu Gao and Kai Fu (University of Utah, USA)

17:00

Near-Vertical Non-Plasma HCl Gas Etching on (011) β - Ga₂O₃

Takayoshi Oshima and Yuichi Oshima (National Institute for Materials Science, Japan)

17:15

Dry Etch Damage Mitigation in (001) β - Ga₂O₃ Schottky Diodes Using Hot-H₃PO₄

Steve Rebollo (University of California, Santa Barbara, USA); Wolfgang Buchmaier (UCSB, USA); Sriram Krishnamoorthy (University of California Santa Barbara, USA); James Speck (UCSB, USA)

Technical Program: Tuesday, August 5

17:30 – 19:30

Poster Session

Location: Cleone Peterson Eccles Alumni House

Address: 155 SOUTH CENTRAL CAMPUS DRIVE SALT LAKE CITY, UT 84112

Crack Formation in Strained β -(Al_xGa_{1-x})₂O₃ Films Grown on (010) β -Ga₂O₃ Substrates

Dorian P Luccioni and Kenny Huynh (University of California Los Angeles, USA); Michael E Liao (Apex Microdevices, USA); Kaicheng Pan, Brandon S. Carson and Lezli Matto (University of California Los Angeles, USA); Marko J Tadjer and James Spencer S Lundh (US Naval Research Laboratory, USA); Kohei Sasaki (Novel Crystal Technology, Inc., Japan); Hannah N. Masten and Jennifer Hite (US Naval Research Laboratory, USA); Michael Mastro (Naval Research Laboratory, USA); XianRong Huang and Michael Wojcik (Advanced Photon Source, Argonne National Laboratory, USA); Akito Kuramata (Novel Crystal Technology, Inc., Japan); Karl D Hobart (US Naval Research Laboratory, USA); Mark Goorsky (University of California, Los Angeles, USA)

Advanced MOCVD Growth and TEM Analysis of Rutile GeO₂

Imteaz Rahaman, Botong Li, Hunter Ellis, Michael Scarpulla and Kai Fu (University of Utah, USA)

Distinction Between (001) and (-101) Plane Orientations of β -Ga₂O₃ Crystals Grown by EFG Method

So-min Shin (Dong Eui University, Korea (South)); Yunjin Kim (DongEui University, Korea (South)); Dae-Uk Kim (DONG-EUI University, Korea (South)); Won-Jae Lee and Junggon Kim (Dong-Eui University, Korea (South))

Improving Thermal Management in β -Ga₂O₃ Power Devices Through Interface Engineering: A First-Principles Study

Sanjay Gopalan (North Carolina State University, USA); John Muth (NC State University, USA); Ki Wook Kim (North Carolina State University, USA)

Understanding Anisotropic Breakdown Behavior in β -Ga₂O₃ Through TCAD and Experimental Analysis of JTE Structures

Mohamed Torky and Shariare Hossain Rabbi (University at Albany, USA); Daehwan Chun and Youngkyun Jung (Hyundai Motor Company, Korea (South)); Bongmook Lee (SUNY Polytechnic Institute, USA); Woongje Sung (University at Albany, USA)

Technical Program: Tuesday, August 5

Measurement Geometries and Depth Sensitivity for High Resolution X-Ray Diffraction Measurements: Homoepitaxial β -Ga₂O₃

Mark Goorsky (University of California, Los Angeles, USA); Michael E Liao (Apex Microdevices, USA); Brandon S. Carson (University of California Los Angeles, USA); Marko J Tadjer and Karl D Hobart (US Naval Research Laboratory, USA)

Remote Hydrogen Plasma Interplay with Ga₂O₃ Carbon, Oxygen, and Gallium Defects

Carlos R DeLeon (Ohio State University, USA); Lingyu Meng (The Ohio State University, USA); Daram N Ramdin (Air Force Research Labs- Contractor & Core4ce, USA); Jade Cowsky (Ohio State University, USA); Hongping Zhao (The Ohio State University, USA); Leonard Brillson (Ohio State University, USA)

High-Frequency Electron Paramagnetic Resonance Generalized Spectroscopic Ellipsometry Characterization of Cr-Doped Gallium Oxide

Viktor Rindert (Lund University, Sweden); Zbigniew Galazka (Leibniz Institute for Crystal Growth - IKZ, Germany); Mathias M Schubert (University of Nebraska-Lincoln & Lund University, USA); Vanya Darakchieva (Lund University, Sweden)

Mitigating Interfacial Si Conductivity in β -Ga₂O₃ Thin Films with Fe Compensation

Brenton A. Noesges (Air Force Research Laboratory, USA & Core4ce, USA); Prescott Evans (Azimuth Corporation, USA); Jian Li (Air Force Research Laboratory, USA); Mark Gordon (Air Force Research Laboratory & University of Dayton, USA); Daram N Ramdin (Air Force Research Labs- Contractor & Core4ce, USA); Shin Mou, Adam Neal and Thaddeus Asel (Air Force Research Laboratory, USA)

Nucleation and Evolution of GeO₂ Grown on Sapphire Substrates by MOCVD

Botong Li and Imteaz Rahaman (University of Utah, USA); Bobby Duersch (Electron Microscopy and Surface Analysis Laboratory, the University of Utah, USA); Hunter Ellis and Kai Fu (University of Utah, USA)

Low-Pressure CVD of Sn- and Ge-Doped β -Ga₂O₃: Tunable Doping, Promising Mobility, Schottky Diodes, and Insights from DFT

Ahmed Ibreljic, Saleh Ahmed Khan, Ibrahim Isah, Stephen Lam and A F M Anhar Uddin Bhuiyan (University of Massachusetts Lowell, USA)

Technical Program: Tuesday, August 5

Investigating the Epitaxial Growth of Hexagonal ϵ -(In_xGa_{1-x})₂O₃ on AlN for High Power and Extreme Environment Applications

Maria Sultana and Ariful Haque (Texas State University, USA)

Effect of N₂ Atmosphere Annealing on Impurity Distribution and Crystallinity of 4N β -Ga₂O₃ Single Crystals Grown by EFG Method

A-Ran Shin and Tae-Hun Gu (Pukyong National University, Korea (South)); Yun-Ji Shin and Seong-Min Jeong (Korea Institute of Ceramic Engineering and Technology, Korea (South)); Si-Young Bae (Pukyong National University, Korea (South))

TEM Investigation of Point-Defect Formation in Beta-(Al_xGa_{1-x})₂O₃ Single Crystals

Arub Akhtar, Thilo Remmele, Saud Bin Anooz and Ta-Shun Chou (Leibniz-Institut für Kristallzüchtung (IKZ), Germany); Andreas Fiedler (Leibniz Institute for Crystal Growth - IKZ, Germany); Jana Rehm, Chen-Hsun Lu and Changming Liu (Leibniz-Institut für Kristallzüchtung (IKZ), Germany); Tobias Schulz (Leibniz-Institut für Kristallzüchtung, Germany); Zbigniew Galazka and Martin Albrecht (Leibniz Institute for Crystal Growth - IKZ, Germany); Andreas Popp (Leibniz-Institut für Kristallzüchtung, Germany)

Machine Learning Guided Microscopy for Vacancy Detection in β -Ga₂O₃

Shaon Das and Baishakhi Mazumder (University at Buffalo, USA)

Vertically Conducting β -Ga₂O₃ Diodes on 4H-SiC Substrate as Short Wavelength (<245 nm) Switches/Detectors

Tahir Hassan and Nifat Jahan Nipa (University of South Carolina, USA); Kai Fu and Botong Li (University of Utah, USA); Rafiqul Islam and Michel Francois (Cactus Materials Inc., USA); Iftikhar Ahmad (University of South Carolina, USA)

Nanoscale Thermal Transport in Ion-Beam-Exfoliated β -Ga₂O₃ Nanomembranes

Azat Abdullaev (Nazarbayev University, Kazakhstan & National Laboratory Astana, Kazakhstan); Lyazzat Mukhangaliyeva and Kairolla Sekerbayev (National Laboratory Astana, Kazakhstan); Duarte Esteves (Instituto Superior Técnico, University of Lisbon, Portugal); Miguel Cardoso Pedro (INESC MN, Portugal); Luís Manuel Cerqueira Lopes Alves (C2TN, Portugal); Katharina Lorenz and Marco Peres (Instituto Superior Técnico, University of Lisbon, Portugal); Zhandos Utegulov (Nazarbayev University, Kazakhstan)

Technical Program: Tuesday, August 5

Defects in Atomic Layer Deposited Polycrystalline HfO_2 on $(\bar{1}201)$ $\beta\text{-Ga}_2\text{O}_3$

Khushabu Agrawal and Paolo Latorraca (Tyndall National Institute Cork, Ireland); Adam A Gruszecki, Joy Roy, Robert Wallace and Chadwin D Young (University of Texas at Dallas, USA); Paul Hurley and Karim Cherkaoui (Tyndall National Institute, Ireland)

Modulating Interface and Bulk Properties in ALD Al_2O_3 on $\beta\text{-Ga}_2\text{O}_3$ with Spatially Selective Oxidants

Adam A Gruszecki and Joy Roy (University of Texas at Dallas, USA); Khushabu Agrawal and Paolo Latorraca (Tyndall National Institute Cork, Ireland); Karim Cherkaoui and Paul Hurley (Tyndall National Institute, Ireland); Robert Wallace and Chadwin D Young (University of Texas at Dallas, USA)

In Situ Study of Crystal Quality and Phase Transition of Ga_2O_3 and GeO_2 at High Temperatures Up to 1000 °C by XRD

Botong Li and Imteaz Rahaman (University of Utah, USA); Bobby Duersch (Electron Microscopy and Surface Analysis Laboratory, the University of Utah, USA); Hunter Ellis and Kai Fu (University of Utah, USA)

Defect Kinetics in $\beta\text{-Ga}_2\text{O}_3$: Sequential Quenching Simulations for Thin Films and Bulk Crystals

Khandakar Aaditta Arnab and Michael Scarpulla (University of Utah, USA)

Orientation Dependence of Near Surface Open Volume Defects in Beta- Ga_2O_3 Investigated with Positrons

Marc H Weber (Washington State University, USA & Institute for Materials Research (IMR), USA)

High Quality Ga_2O_3 on Sapphire to Achieve Fast Solar-Blind Photodetectors with High Detectivity

Chen He (University of Chinese Academy and Science)

Numerical Simulation and Optimisation of Hot-Zone Configurations for $\beta\text{-Ga}_2\text{O}_3$ Crystal Growth via the Vertical Bridgman Method

Seora Son (AXEL Co, Ltd., Korea (South)); Ga-Bin Kim, Dong-Jun Lee, Su-Min Choi, Hwang-Hee Lee and Dong-Jin Lee (AXEL, Korea (South)); Dae-Uk Kim (DONG-EUI University, Korea (South)); Junggon Kim, Kwang-Hee Jung and Won-Jae Lee (Dong-Eui University, Korea (South)); Jin-Ki Kang (AXEL, Korea (South))

Technical Program: Tuesday, August 5

Generative Co-Design of Ga₂O₃ Devices for Coupled Electrical, Thermal, and Mechanical Performance

Miguel Aguilo (Morphorm LLC, USA); Michael Scarpulla (University of Utah, USA)

The Study on Surface Properties of Various Crystal Planes Obtained from Bulk β -Ga₂O₃ Single Crystals Grown by the EFG Method

Yunjin Kim (DongEui University, Korea (South)); So-min Shin (Dong Eui University, Korea (South)); Dae-Uk Kim (DONG-EUI University, Korea (South)); Junggon Kim and Won-Jae Lee (Dong-Eui University, Korea (South))

A Surface Potential Based Analytical C-V Model of a Double-Gate Vertical Fin-Shaped Ga₂O₃ Power Transistor

Twisha Titirsha, Showmik Singha, Md Maruf Hossain and Sazia A. Eliza (University of Missouri, USA); Syed Islam (University of Missouri-Columbia, USA)

Simulation and Performance Evaluation of AlN/ β -Ga₂O₃ HEMTs for Next-Generation Ultrawide Bandgap Power Devices

Md Maruf Hossain (University of Missouri, USA & University of Missouri-Columbia, USA); Showmik Singha and Twisha Titirsha (University of Missouri, USA); Sazia Eliza and Syed Islam (University of Missouri-Columbia, USA)

Crystallographic HCl Gas Etching for Fabrication of β -Ga₂O₃/Air-Gap Structures on (100) Substrates

Takayoshi Oshima and Yuichi Oshima (National Institute for Materials Science, Japan)

Sponsor Posters:

S1. *Novel Crystal Technology Inc.*

S2. *Taiyo Nippon Sanso*

S3. *Klar Scientific*

S4. *Kyma Technologies*

S5. *Agnitron Technology*

Technical Program: Wednesday, August 6

08:00 - 08:30

Registration

08:30 - 09:30

Plenary Talk - The Roadmap Towards Ga₂O₃ Technology Insertion

Speaker: Andrew Green (Air Force Research Lab)

09:30 - 10:30

Technical Session 9: Transistors

Session Chair: Nolan Hendricks (Air Force Research Lab)

09:30

1.8 kV Multi-Fin β - Ga₂O₃ Vertical FinFET with Field Oxide Exhibiting a PFOM of 1 GW/cm²

Saurav Roy and Chinmoy Nath Saha (University of California Santa Barbara, USA); Carl Peterson (UC Santa Barbara, USA); James Speck (University of California, Santa Barbara, USA); Sriram Krishnamoorthy (University of California Santa Barbara, USA)

09:45

Enhancement-Mode Vertical β - Ga₂O₃ U-Trench MOSFETs Featuring in-Situ Mg-Doped Current Blocking Layers

Walid Amir (University at Buffalo, USA); Sudipto Saha (SUNY Buffalo, USA); Jiawei Liu (The State University of New York, USA & University at Buffalo, USA); Lingyu Meng, Dong Su Yu and Hongping Zhao (The Ohio State University, USA); Uttam Singisetti (SUNY Buffalo, USA)

10:00

β -Ga₂O₃ Sub-Micron FinFETs Modulating > 3 x 1E13 cm⁻² Charge Density and 109 on/off Ratio

Nabasinghu Das and Advait Gilankar (Arizona State University, USA); Cameron A Gorsak, Salil A Paranjape, Pushpanshu Tripathi and Hari P Nair (Cornell University, USA); Nidhin Kurian Kalarickal (Arizona State University, USA)

Technical Program: Wednesday, August 6

10:15

High-Voltage β - Ga2O3 MOSFET with Staircase Field Plate Design and 400 V Dynamic Switching

Shivam Sharma (University of Buffalo, USA); Sudipto Saha (SUNY Buffalo, USA); Noor Jahan Nipu (The State University of New York at Buffalo, USA); Walid Amir (University at Buffalo, USA); Jiawei Liu (The State University of New York, USA & University at Buffalo, USA); Partha Chakraborty (CFD Research Corporation, USA); Uttam Singiseti (SUNY Buffalo, USA)

10:30 – 11:00

Coffee Break

11:00 – 12:00

Technical Session 10: Diodes & Thermal Management

Session Chair: Nidhin Kurian Kalarickal (Arizona State University)

11:00

Near-Ideal 1D Thermionic Field Emission Current in Vertical β - Ga2O3 Schottky Diodes via Ultra-High- κ Sputtered BaTiO3 Field Management

Kyle Liddy (AFRL, USA); Nolan Hendricks (Air Force Research Lab, USA); Weisong Wang (Wright State University Lake Campus, USA); Kevin Leedy (Air Force Research Laboratory, USA); Andrew Green (AFRL, USA)

11:15

Orientation-Dependent β - Ga2O3 Heterojunction Diode with Atomic Layer Deposition (ALD) Grown NiO

Yizheng Liu (University of California Santa Barbara, USA); Shane M.W. Witsell and John F. Conley (Oregon State University, USA); Sriram Krishnamoorthy (University of California Santa Barbara, USA)

11:30

An Aerosol Jet Printed Heat Spreader Material for Thermal Management of Gallium Oxide Devices

Laura C Davidson (KBR, USA); Nicholas Sepelak (KBR, Inc., USA); Roberto Aga (KBR, USA); Judit K Beagle, Elizabeth Sowers, Carrie Bartsch and Andrew Green (AFRL, USA)

Technical Program: Wednesday, August 6

11:45

Improved Thermal Performance of Gallium Oxide Devices Through the Metal-Embedded Chip Assembly Process

Judit K Beagle and Elizabeth Sowers (AFRL, USA); Daniel M Dryden (Air Force Research Laboratory, USA)

12:00

A Field Plate Study on Large-Area β -Ga₂O₃ Transistors for Field Management in Power Switching Devices

Nicholas P Sepelak (KBR, USA & Air Force Research Laboratory, USA); Nolan Hendricks (Air Force Research Lab, USA); Kyle Liddy and Elizabeth Sowers (AFRL, USA); Laura C Davidson (KBR, USA); Joshua Piel (Air Force Research Lab, USA); Weisong Wang (Wright State University Lake Campus, USA); Judit K Beagle (AFRL, USA); Joshua T Buontempo, Cameron A Gorsak, Katie Gann and Hari P Nair (Cornell University, USA); Kevin Leedy, Daniel M Dryden and Ahmad Ehteshamul Islam (Air Force Research Laboratory, USA); Andrew Green (AFRL, USA)

12:30 – 14:00

Working Lunch Break

Expert panel: Lessons learned from incumbent technologies and applications for Ga₂O₃

Moderator: Nolan Hendricks (Air Force Research Lab)

Panelists:

1. SiC Power Semiconductor Commercialization: Overcoming Key Barriers and Lessons Learned for Novel Material Systems

Victor Veliadis (North Carolina State University)

2. Photoconductive Power Semiconductor Devices and Potential for Gallium Oxide

Sudip Mazumder (University of Illinois)

3. Beyond the Die: Key Elements for Successful Adoption

Alan Mantooth (University of Arkansas)

Technical Program: Wednesday, August 6

14:00 – 15:30

Technical Session 11: Sapphire & Devices for extreme environment applications

Session Chair: Uttam Singiseti (University at Buffalo)

14:00 – 14:30

Invited Talk - Reaching beyond Diamond to Sapphire a 7 eV Semiconductor

Speaker: Darrell Schlom (Cornell University)

Session Chair: Uttam Singiseti (University at Buffalo)

14:30

Electrothermal Co-design of Vertical β - Ga2O3 Schottky Diodes with High Permittivity Dielectric Field Plate for High-field and Thermal Management

Emerson J. Hollar and Ahsanul M Audri (Iowa State University, USA); Chung-Ping Ho and Jingjing Shi (University of Florida, USA); Esmat Farzana (Iowa State University, USA)

14:45

Heavy Ion Single Event Effects (SEE) Testing of kV-Class Lateral Gallium Oxide MOSFETs

Shivam Sharma (University at Buffalo, USA); Andrew L Sternberg (Vanderbilt, USA); Animesh Datta (University at Buffalo, USA); Noor Jahan Nipu (The State University of New York at Buffalo, USA); Sudipto Saha (SUNY Buffalo, USA); Walid Amir (University at Buffalo, USA); Jiawei Liu (The State University of New York, USA & University at Buffalo, USA); Christina DiMarino (Virginia Tech & Center for Power Electronics Systems (CPES), USA); Partha Chakraborty (CFD Research Corporation, USA); Uttam Singiseti (SUNY Buffalo, USA)

15:00

Influence of Doping Concentration and E-Field on Radiation Response in MOCVD β - Ga2O3 Schottky Diodes

Joe McGlone, Hemant Jagannath Ghadi and Randy Carver (The Ohio State University, USA); Jonathan Heile (Sandia National Laboratory, USA); Lingyu Meng, Dong Su Yu, Hongping Zhao and Aaron Arehart (The Ohio State University, USA); Edward Bielejec (Sandia National Laboratory, USA); Steven Ringel (the Ohio State University, USA)

Technical Program: Wednesday, August 6

15:15 – 15:45

Coffee Break

15:15 – 17:30

Technical Session 12: Novel devices & dynamic performance Session Chair:

Esmat Farzana (Iowa State University)

15:15 – 16:45

Invited Talk - Recent advancements in Gallium Oxide based power electronics

Speaker: Faisal Khan (National Renewable Energy Laboratory)

16:15

Effects of Spatially Resolved Heavy Ion Irradiation on Ga₂O₃ MOSFETs

Daram N Ramdin (Air Force Research Labs- Contractor & Core4ce, USA); Eric O' Quinn (University of Tennessee, Knoxville, USA); Adam Charnas (Air Force Research Laboratory, USA); Kay-Obbe Voss (GSI Helmholtz Center, Germany); Cameron A Gorsak and Hari P Nair (Cornell University, USA); Maik K. Lang (University of Tennessee, Knoxville, USA); Andrew Green (AFRL, USA); Thaddeus Asel, Shin Mou and Adam Neal (Air Force Research Laboratory, USA)

16:30

Evaluation of a β - Ga₂O₃ MSM Detectors for Proton Therapy

Hunter Ellis, Imteaz Rahaman, Jared Miller, Ajayvarman Mallapillai, Apostoli Hillas, Vikren Sarkar and Kai Fu (University of Utah, USA)

16:45

Binary Phase-Only Gallium Oxide Diffractive Optical Element for Beam Shaping

Wei Jia (The University of Utah, USA); Steve Blair (University of Utah, USA); Berardi Sensale Rodriguez (The University of Utah, USA)

17:00

Application of α - Ga₂O₃-Based Schottky Barrier Diode to Microwave Rectenna

Takeru Wakamatsu, Shizuo Fujita and Hikaru Ikeda (Kyoto University, Japan); Kentaro Kaneko (Kyoto University and Ritsumeikan University, Japan); Yasuo Ohno and Tomomi Hiraoka (Laser Systems Inc., Japan); Katsuhisa Tanaka (Kyoto University, Japan)

Technical Program: Wednesday, August 6

17:15

**Dynamic Breakdown Voltage and Overvoltage Margin Under Pulsed Conditions
in β -Ga₂O₃ Based Devices**

Harsh Raj (Indian Institute of Science, India); Mayank Shrivastava (Indian Institute of Science Bangalore, India)

17:30

Closing Remarks

Co-Chairs: Sriram Krishnamoorthy (University of California - Santa Barbara),
Michael Scarpulla (University of Utah)